

### SOCIETY FOR INFORMATION DISPLAY

## SID-ME Chapter Spring 2004 meeting and **SID-MEC General Meeting** "OLED display technology and applications" March 25-26, 2004

at Covion, Hoechst Industrial Park, Frankfurt, Germany

The SID-ME Chapter Spring 2004 meeting on "OLED display technology and applications" was organized at the Covion site situated in the Hoechst Industrial Park Frankfurt/Main-Germany. The Hoechst Industrial Park is a center for innovation in chemicals where some 70 companies employ about 25 thousand people. One of these is Covion an "OLED shooting star" for the future. H. Schenk (Managing Director of Covion and conference chair) and J. Kimmel (European director of SID and program chair) opened the meeting. The conference comprised 21 oral presentations, the SID-MEC general meeting, a Covion tour and last but certainly not least a conference dinner at the ship "Goethe" cruising the Main river. More than 90 people attended the meeting, and it was noted that the consistently high number of participants, on this and previous SID-ME chapter meetings, indicates a general approval of the program quality and the networking opportunity.

#### Session 1, March 25, afternoon New developments in OLED's

H. Becker (Covion Organic Semiconductors GmbH, Frankfurt) talked about new material approaches for OLED and PLED displays. In both solvent based and sublimation based materials significant improvements were reported. For red and green good efficiency and promising lifetime is reached. For blue more work is needed.

I. Underwood (MicroEmissive Displays Ltd., UK) discussed the realization of light emitting polymer micro displays. The smallest lowest-power color displays in the world? A very nice demo was shown to illustrate the point.

J.Blochwitz-Nimoth (Novaled GmbH, Dresden) presented results on highly efficient OLEDs for full color active matrix displays. Using newly developed doped contact layers an efficiency improvement and a lowering of the operation voltages are achieved. Also, integration in an a-Si active matrix back plane allows efficient top-emission.

A. Giraldo (Philips Research, The Netherlands) presented research on an active matrix polymer OLED display with optical feedback. It was shown that the internal compensation of OLED device ageing via a photosensitive circuit element, TFT or diode, is a most attractive route to alleviate burn-in and discoloration in AMOLED displays.

#### Session 2, March 25, afternoon OLED technology and manufacturing

F. Pieralisi (University of Stuttgart, Germany) gave a talk on active matrix OLED back plane circuit technology. The required control of short range and long-range uniformity in low temperature poly-silicon (LTPS) TFT's and the need for compensation using a current mirror circuit was elucidated.

M. Ueltzen (Fraunhofer Alliance Polymer Surfaces, Germany) presented an overview of the activities of the Fraunhofer Alliance Polymer Surfaces (POLO) in ultra-barrier films. This alliance comprises institutes at six locations and covering seven fields of competence that generates a coherent effort to establish and industrialize ultra-barrier films for display applications.

A.Gurke (Applied Films GmbH & Co.KG, Germany) discussed the development of a vertical inline vacuum deposition system for OLED production. A cycle time of 60 seconds and thickness uniformity of less than 5% is realized for substrates with a maximum size of 400  $\times$  640 mm<sup>2</sup>.

H. Kopola (Technical Research Center of Finland) talked about roll-to-roll fabrication technologies for OLED devices. Objective is to fabricate simple OLED displays in a cost-effective manner. Although there are many challenges it was shown that traditional roll-to-roll printing techniques may be used successfully in the fabrication of OLED layers and structures. D. Buchhauser (Siemens AG & Osram Opto Semiconducter, Germany) discussed tailored color filtering of a white broadband emitter, as a possible route to full color displays. Using known spectral emission and degradation characteristics an optimum system combination for emitter, design and color filter can be calculated.

# Session 3 March 25, afternoon Large-area OLED's

T. Beierlein (IBM Research, Switzerland) presented a talk on advanced OLED technology: the enabler for the world's largest (20-inch) full-color a-Si active matrix OLED display. A cooperative effort of IBM, CMO, IDTech and Covion succeeded in optimizing a top-emission structure, material performance (both the OLED emitter and the a-Si semiconductor), and driving circuit, in such a way that an impressive 20-inch demonstrator could be realized (shown on the SID'03 exhibition in Baltimore). IBM Zurich contributed the modeling. Sufficient lifetime was anticipated.

H. Schemmann (Thomson, France) discussed the issues with OLED for video displays. There was a clear contrast with the previous speaker. It was stated that the high luminance required for video displays involves a high drive current, which implies a lifetime decrease and large ohmic losses. Also burnin occurs because the RGB-materials degrade with a different rate. Further improvements in emitter material, especially blue, manufacturing (solution or evaporation technology) and a-Si technology (circuit, material) are required.

#### **Conference dinner**

The meeting included a conference dinner at the ship 'Goethe'; see picture. The restaurant ship was reserved for the occasion and going for dinner felt like taking part in a European display endeavour. On steady course and with a stimulating view on nightly 'Mainhattan' the tasty buffet diner was indeed enjoyed very much.



J.Kimmel (Director of SID-MEC) and K.Skarp (the new Chair of SID-MEC) are ready to board the ship 'Goethe' for the conference dinner.

#### Session 4, March 26, morning Keynote presentation

B. Young (Display Search Inc., USA) presented an extensive overview of OLED market status and development forecast embedded in an all display technology covering perspective. While the large flat TV market volume for LCD and PDP is growing strongly, the display component maker profits are governed by the supply/demand ratio. For PDP an undersupply exists. For OLED's the market volume is still limited, but a steady and consistent development is anticipated. Small molecule OLED is much larger than polymer OLED and about 2 years ahead in development. As yet there is a cautious industrial commitment.

#### Session 5, March 26, morning European networks and display education

E. Haskal (Philips Research, The Netherlands) was allowed a few minutes at the beginning of this session to sketch the outline of the "Flexible display" proposal recently granted in the 6th framework program of the European Commission.

E. Maiser (DFF, German Flat Panel Display Forum) discussed recent advances in creating a European FPD Federation- the ADRIA project. The ADRIA project stands for Advanced Display Research Integration Action and involves work packages on context mapping, road mapping, education etc. The aim is to create a "one-stop-shop" for FPD in Europe.

W. Mildner (PolyIC GmbH & Co. KG, Germany) talked about strengthening Europe's competence position by new education efforts. The founding of the MikroFORUM Academy, a Private Graduate School for High-technology with a Pilot Course "Display Masters" was discussed. A kick-off workshop is planned for end of June.

*C. Williams (Logystyx UK Ltd., UK)* presented a talk on display education and networking in the U.K. Emerging technologies exceed the capabilities and resource of any single company to research, develop and exploit by themselves. Collaboration between companies (and academic institutions) and networking and education fill the gaps in resources and staff training. In the U.K. FLEXYNET a new network for companies working in flexible displays & flexible electronics started this year. Collaboration with European and other activities is sought.

A. Dore (Le Club Visu, France) the last speaker in this session reviewed the training sessions given by the Club Visu in France. Several day seminars for basic education and specialist training are given yearly, where recognized specialists from the industry and the academia give the lectures.

#### **SID-MEC General Meeting**

J. Kimmel (Director SID-MEC) and K. Skarp (nominated for chair) headed the SID-MEC general meeting, where the activities of the chapter were reported.

The election of the officers of the SID-ME chapter for the coming period took place. The proposed candidates were elected unanimously. The new Chapter committee is now composed as follows: Kent Skarp (Chair), Gerrit Oversluizen (Vice-Chair), Herbert de Smet (Secretary), Jutta Rasp (Treasurer). The abdicating officers Norbert Fruehauf (Chair), Andre van Calster (Secretary), and Frank Rochow (Treasurer) are thanked for their contribution to the society.

The membership fluctuates somewhat in line with conference activity.With about 530 members at the end of February 2004 the SID-ME chapter remains the second largest chapter. The healthy financial situation of the Chapter was explained. Two members approved the administration. For 2004 a larger than usual spending is envisaged, due to the 10th anniversary occasion. Also a SID-MEC Student Award of 1500 Euro was installed to further and acknowledge outstanding display work. More details on the award and the application procedure are given below.

Also the next meeting was announced. The fall'04 meeting is to be held on 11 and 12 of October in Stuttgart (see further information below).

# Session 6, March 26, morning Display applicability issues

K. Bjorknas (Nokia Research Center, Finland) talked about OLED performance from a usability point of view. Options and requirements for indoor and outdoor display applications were discussed. OLED displays are especially suited for high value products with full color high-resolution video. Brightness control for dark environments is a must.

K. Blankenbach (University of Applied Sciences Pforzheim, Germany) presented visualization software for simulation of OLED ageing. Easy to use software was developed for visualization of OLED degradation effects, which could also be used for PDP and CRT. This can be used to adapt device and application.

# Session 7, March 26, afternoon OLED applications

*C. Winnewisser (C.S.E.M., Switzerland)* gave a presentation on low cost patterning of polymer light-emitting logos by printing methods. The possibilities with screen-printing, ink-jet printing and mold printing were discussed.

S.Riehemann (Fraunhofer Institute for Applied Optics and Precision Engineering, Germany) talked about OLED based projection systems for optical metrology. An interesting application where OLED light sources are applied to probe object dimensions was discussed.

E. Nielsen (SeeReal Technologies GmbH, Germany) presented the last talk on opportunities for OLEDs in 3-D displays. Mostly 3-D technology options and applications in general were discussed. It is however clear that OLEDs being thin fine pitch enabling displays are well suited to take part in the increasingly 3-D display future.



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#### **Covion tour**

In conjunction with this SID-ME meeting there was an opportunity to visit the Covion facilities. Most of the participants joined in for a show around of Covion's activity, which was given with great enthusiasm. Covion can deliver OLED materials, both small molecules and polymers. Covion started research work in 1992. Nowadays about 75 people work in research, application and development, and about 35 people run the production on a hired-in basis. In research new monomer and polymer materials are synthesized. In the application department these are functionally tested in devices. Those passing initial tests are fabricated in larger quantity in development, and a final selection reaches the production stage. The up scaling involved is illustrated below.



#### **Closing remarks**

The spring'04 SID MID-Europe meeting was a successful event organized in a European centre for innovation in chemicals. It was another contribution to an innovative spirit for enterprise in displays in Europe.

Gerrit Oversluizen



Illustrations of the up-scaling from development to production equipment for OLED materials

## Coming Event: SID-ME SID Mid-Europe Chapter 10th Anniversary Meeting

11-12 Oct. 2004, at the University of Stuttgart

**Special Topics:** 

## Organic and Inorganic Active Matrix, Multimedia Displays, Flexible Displays and Process Technology for Displays

Visit the website for latest information: http://www.lfb.uni-stuttgart.de/sidme

### **SID-ME Chapter committee**

The SID-ME Chapter committee is now formed by: Prof. Dr. K. Skarp (chair), Dalarna University, Forskargatan 3, SE-781 70 Borlänge, Sweden Tel.: +46-23-778628 Mobile: +46-70-6214175 E-mail: ksa@du.se Dr. G. Oversluizen (vice-chair), Philips Research, Prof. Holstlaan 4, 5656 AA, Eindhoven, The Netherlands, Tel.: +31 40 2742454, Fax: +31 40 274 43 35, E-mail: gerrit.oversluizen@philips.com Prof.Dr. H. De Smet (secretary), University of Gent, St.-Pietersnieuwstraat 41, B-9000 Gent, Belgium, Tel.: +32 9 264 3459, Fax: +32 9 264 35 94, E-mail: Herbert.desmet@elis.rug.ac.be J. Rasp (treasurer), Europe DPT.

# Additional members of the SID ME Chapter committee are:

Dr.-Ing.N.Frühauf, Universität Stuttgart, Allmandring 3B, D-70550 Stuttgart-Vaihingen, Germany, Tel.:+49 711 685 6922, Fax: +49 711 685 6924. Dr.Michael E. Becker, Display-Metrology & Systems, Marie-Alexandra Str. 44, D 76135 Karlsruhe-Germany, Tel./Fax: +49 721 981 2268 E-mail: m.Becker@display-metrology.com Dr. W.Becker, Merck KGaA, Frankfurter Str. 250, D-64293 Darmstadt, Germany, Tel.: +49 6151 72 7360 ; Fax: +49 6151 72 3132 E-mail: werner.becker@merck.de Prof.Dr.-Ing. E. Lüder, University of Stuttgart, Pfaffenwaldring 47, D-70550 Stuttgart-Vaihingen, Germany, Tel.: +49 711 68 57 330 or +49 711 68 57 332, Fax: +49 711 685 7311. E-mail: ernst.lueder@ins.uni-stuttgart.de Prof.Dr. P. Maltese, University La Sapienza, Via Marmorata 169, I-00153 Roma, Italy, Tel.: +39 644 585 428, Fax: +39 647 42 647. Dr. M. Schadt, Rolic Research Ltd, Gewerbestrasse 18, CH-4123 Allschwil, Switzerland, Tel.: +41 61 487 22 22, Fax: +41 61 487 22 88, E-mail: martin.schadt@rolic.com Dr. D. Theis, Siemens AG, Tel.: +49 89 636 40550, Fax.: +49 89 636 40554, E-mail: dietmar.theis@siemens.com Dr.P.G.Wierer, Balzers Thin Films, P.O. Box 1000, FL-9496 Balzers/Liechtenstein Tel.: +423 388 47 42. Fax: +423 388 54 05 E-mail: wip@btf.balzers.net Dr.J.Bruinink, Philips Research, Prof. Holstlaan 4, 5656 AA, Eindhoven, The Netherlands, Tel.: +31 40 2743989, Fax: +31 40 274 43 35, E-mail: Jaap.Bruinink@philips.com

### European officer of the SID:

.Lic.Tech. *J.Kimmel* (director), Nokia Research Center, P.O. Box 100, FIN-33721 Tampere, Finland, Tel.: +358 7180 35484, Mobile: +358 50 48 35484, Fax: +358 7180 35322, E-mail: jyrki.kimmel@nokia.com

## SID payment.

The SID annual membership fee amounts US\$ 75. Please note that the membership is now a rolling membership, which means that it runs 12 months from the month in which the payment was made. For more information see the SID website www.sid.org.

We encourage our members to pay directly to SID-HQ in the USA, but if they want to pay to the ME-Chapter directly the annual fee should be EUR 90 with all bank fees covered by the member !

In case of direct payment to the SID-ME Chapter the payment in EURO should be done to

Please indicated your name on the remittance papers.	
Account name:	Frank Rochow, SID-ME
Bank code:	BLZ 100 500 00
at:	Berliner Sparkasse, Berlin, Germany
Account no.:	206 020 1104

## The Newsletter.

If you want to place an article in the Newsletter, which is interesting for the European display society, please send it to: G. Oversluizen, fax: +31 40 274 4335, E-mail: gerrit.over-sluizen@philips.com

## **SID-ME Chapter Student Award**

### Call for SID-ME Chapter Student Award

The SID-ME Chapter Student Award is given for an outstanding scientific or technical achievement in, or contribution to, research on information display. The applicant is a student at a university/institute in the SID-ME region. The award amounts to 1500 Euro, with the obligation to present the contribution at the SID-MEC meeting where the award is presented. The conference fee is waived. The applicant must be a member of SID. For information on student membership, see below. The application deadline is June 30, 2004.

### **Application for SID-ME Chapter Student Award**

Name:
Institute/University:
Address:
Title of contribution:
Abstract (100-150 words):
References ( SID-ME member):

The application should be submitted to the award committee consisting of: Prof.Dr.-Ing. N. Frühauf, Universität Stuttgart, Allmandring 3B, D-70550 Stuttgart-Vaihingen, Germany, Tel.: +49 711 685 6922, Fax: +49 711 685 6924. E-mail: norbert.fruehauf@lfb.uni-stuttgart.de Dr. G. Oversluizen, Philips Research, Prof. Holstlaan 4, 5656 AA, Eindhoven, The Netherlands, Tel.: +31 40 2742454, Fax: +31 40 274 43 35. E-mail: gerrit.oversluizen@philips.com Prof. Kent Skarp, Swedish LCD Center, Forskargatan 3, 781 70 Borlänge, Sweden, Tel.: +46 23 77 86 78, Fax: +46 23 77 86 70. E-mail: kent.skarp@du.se

#### SID Student Membership:

At http://www.sid.org you find information on SID student membership. Note the favourable offer of \$5.00 per year for student members.